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 Bachtold, M.; Emmenegger, M.; Korvink, J.G.; Baltes, H.;
 Computer-Aided Design of Integrated Circuits and Systems, IEEE on
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- ☒ 2. **Low-order models for fast dynamical simulation of MEMS micromachined devices**
 Hung, E.S.; Yao-Joe Yang; Senturia, S.D.;
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